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EXTRUSION FREE WET CLEANING PROCESS

Appl. No. : 10/710,522 Confirmation No. : 4521
Applicant : Chung-Chih Chen
Filed : July 18, 2004
TC/A.U. : 1792
Examiner : TADAYYON ESLAMI,
TABASSOM
Docket No. : NAUP0598USA
Customer No. : 27765

Commissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450

AMENDMENT AND REQUEST FOR CONTINUED EXAMINATION

5 In response to the Office action of December 4th, 2007, please amend the
above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2
of this paper.

Remarks begin on page 4 of this paper.

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